

Application/Control No.	Applicant(s)/Patent under Reexamination
10/073,226	YAMATO ET AL.
Examiner	Art Unit
Vickie Kim	1614

SEARCHED					
Class	Subclass	Date	Examiner		
554	057	3/15/2005	VK		
554	035	3/15/2005	VK		
424	66	3/15/2005	VK		
424	67	3/15/2005	VK		
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INTERFERENCE SEARCHED					
Subclass	Date	Examiner			
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SEARCH N (INCLUDING SEARC		)
	DATE	EXMR
CAS/STN ONLINE: CAPLUS REGISTRY	3/15/2005	VK
USPATFUL/EAST JAPIO	3/15/2005	VK
Search Updated	3/15/2005	VK
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